

Notice of References Cited	Application/Control No. 10/566,988	Applicant(s)/Patent Under Reexamination MIURA ET AL.	
	Examiner Seung H. Lee	Art Unit 2876	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,386,459	05-2002	Patrice et al.	235/492
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NON-PATENT DOCUMENTS

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